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## APPLICANTS

Yoshihiro Ito, Nagaokakyo-shi, JAPAN;  
 Michio Kadota, Kyoto, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP03/07055 06/04/2003

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-172301 06/13/2002

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				

## ADDRESS

Joseph R Keating  
 Keating & Bennett  
 10400 Eaton Place  
 Suite 312  
 Fairfax, VA 22030

## TITLE

Semiconductor device and method for manufacturing semiconductor device

FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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